



**RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE REQUESTED  
EXAMINING GROUP 1734**

**PATENT**

**Attorney Docket No. 02887.0271**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

Tetsuya KUROSAWA et al.

Application No.: 10/808,298

Filed: March 25, 2004

For: SEMICONDUCTOR  
MANUFACTURING APPARATUS  
AND METHOD OF  
MANUFACTURING  
SEMICONDUCTOR DEVICE

)  
)  
) Group Art Unit: 1734

) Examiner: Osele, Mark A.

) Confirmation No.: 5493

) Mail Stop AF

Okay to Enter

mao 7-13-06

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT AFTER FINAL**

In reply to the Final Office Action mailed April 5, 2006, the period for response to which extends through July 5, 2006, and pursuant to 37 C.F.R. § 1.116, Applicants propose that this application be amended as follows:

**Amendments to the Claims** are reflected in the listing of claims in this paper.

**Remarks/Arguments** follow the amendment sections of this paper.